

04/12/01
Jc839 U.S. PTO

04-16-01

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Docket No. 005651/ETCH/CHMBR/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Commissioner of Patents and Trademarks
Washington, D.C. 20231

Re: Inventor(s): Michael BARNES and David Palagashvili
Title: PLASMA REACTOR ELECTRODE

Jc921 U.S. PTO
09/834343
04/12/01

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 9 pages.
☒ Drawings totaling 2 pages, ☒ Formal ☐ Informal.
☒ Executed Declaration and Power of Attorney.
☒ Assignment of the invention to **Applied Materials, Inc.**
☒ Assignment Recordation Cover Sheet
☒ Information Disclosure Statement (37 CFR 1.98)

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	16	-20=	0	X\$18.00	\$000.00
Independent Claims	2	-3=	0	X\$80.00	\$000.00
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$710.00

- ☒ The Commissioner is hereby authorized to charge \$710.00 to Deposit Account No. 50-1074.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:
- PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA. 95052**

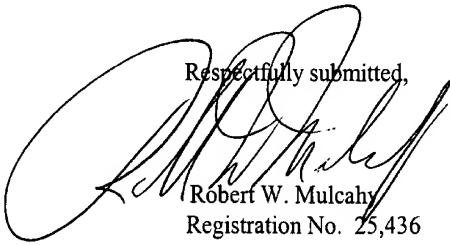
I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No. EL66180502545

Date of Deposit 4-12-2001

Signature Bert Mulcahy

Respectfully submitted,


Robert W. Mulcahy
Registration No. 25,436